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APPLICATION NO.	FILING DATE		FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/083,481	7590	002	Yuko Iwabuchi	29273/559	5826	
KENYON & KENYON EXAMINER			INER			
	EET, N.W., SUI TON, DC 2000			BERMAN, JACK I		
			•	ART UNIT	PAPER NUMBER	
				2881		
	DATE MAILED: 06/05/2002				2	

Please find below and/or attached an Office communication concerning this application or proceeding.

			<u>Khv</u>				
	Application No.	Applicant(s)	0():				
	10/083,481	IWABUCHI ET AL.					
Office Action Summary	Examiner	Art Unit					
	Jack I. Berman	2881					
The MAILING DATE of this communication a Period for Reply	ppears on the cover sheet with	the correspondence addre)\$\$				
A SHORTENED STATUTORY PERIOD FOR REP THE MAILING DATE OF THIS COMMUNICATION - Extensions of time may be available under the provisions of 37 CFR after SIX (6) MONTHS from the malling date of this communication. - If the period for reply specified above is less than thirty (30) days, a relative to reply within the set or extended period for reply will, by state. - Any reply received by the Office later than three months after the mai earned patent term adjustment. See 37 CFR 1.704(b). Status	I. 1.136(a). In no event, however, may a reply eply within the statutory minimum of thirty (3 and will apply and will expire SIX (6) MONTH ute, cause the application to become ABAN	y be timely filed 30) days will be considered timely. S from the mailing date of this comm DONED (35 U.S.C. § 133).	nunication.				
1) Responsive to communication(s) filed on	·						
2a) ☐ This action is FINAL. 2b) ☒ 1	This action is non-final.						
3) Since this application is in condition for allocation closed in accordance with the practice under			nerits is				
Disposition of Claims							
4)⊠ Claim(s) <u>1-16</u> is/are pending in the applicati							
4a) Of the above claim(s) is/are withdo	rawn from consideration.						
5) Claim(s) is/are allowed.							
6)⊠ Claim(s) <u>1-16</u> is/are rejected.							
7) Claim(s) is/are objected to.							
8) Claim(s) are subject to restriction and	or election requirement.						
Application Papers							
9) The specification is objected to by the Examin							
10) ☑ The drawing(s) filed on <u>27 February 2002</u> is/a							
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).							
11) The proposed drawing correction filed on is: a) approved b) disapproved by the Examiner. If approved, corrected drawings are required in reply to this Office action.							
12) The oath or declaration is objected to by the 8	. •						
Priority under 35 U.S.C. §§ 119 and 120		140(a) (d) 02 (9					
13) Acknowledgment is made of a claim for forei	igh phonly under 35 U.S.C. 9	1 19(a)-(u) or (i).					
a)⊠ All b)☐ Some * c)☐ None of:	nto boso boso applicad						
1. Certified copies of the priority docume		diagtion No. 00/424 202					
2. Certified copies of the priority docume	• •		~~~				
 3. Copies of the certified copies of the prapplication from the International E * See the attached detailed Office action for a limited 	Bureau (PCT Rule 17.2(a)).		age				
14) Acknowledgment is made of a claim for dome	stic priority under 35 U.S.C. §	119(e) (to a provisional ap	oplication).				
a) ☐ The translation of the foreign language p 15)☑ Acknowledgment is made of a claim for dome	provisional application has bee	n received.					
Attachment(s)							
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449) Paper No(s)	5) Notice of Info	mmary (PTO-413) Paper No(s). ormal Patent Application (PTO-1					

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The following is a quotation of the second paragraph of 35 U.S.C. 112:

The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.

Claims 11 and 16 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention. In claim 11, a "stage means" cannot store picture information.

Applicant apparently intended to say --storage means--. The claim will be examined in accordance with this interpretation. Similarly, in claim 16, "electron" should read --electrode--.

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1-4, 9, 10, 14, and 15 are rejected under 35 U.S.C. 102(b) as anticipated by or, in the alternative, under 35 U.S.C. 103(a) as obvious over Feuerbaum et al.. Feuerbaum et al. discloses a scanning electron microscope and a method of using it for examining a specimen by scanning an electron beam over the specimen and detecting charged particles emanating from the specimen by means of detector DT and converting these detected charged particles to an electrical signal. Such an examination would inherently reveal any defects in the specimen. Feuerbaum et al. teaches, at lines 56-58 in column 7, that it is advantageous to provide a beam

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blanking system, which comprise a deflector, at a crossover in the electron beam formed by a convergence lens. Feuerbaum et al. also teaches to apply a retarding voltage to decelerate the electron beam before it reaches the specimen. At lines 14-20 in column 9, the patent teaches:

"For the case where measurement means including detector DT is to be utilized for effecting electric potential measurements or spacial measurements on the specimen PR, the final energy level of the beam as it impinges on the specimen PR is preferably such that a charge balance of impinging and departing charge results at the specimen PR."

Since the charge balance of impinging and departing charge on a specimen inherently depends on the nature of the specimen, the teaching of the patent would inherently require changing the magnitude of the retarding voltage based on the nature of the specimen. Feuerbaum et al. does not specify a beam current for the method and apparatus so it cannot be determined whether or not the patented scanning electron microscope anticipates the current range of at least 100nA claimed in the instant application, but even if it does not, such currents are matters for routine experimentation which would be obvious if not anticipated.

Claims 5, 6, 11, and 16 are rejected under 35 U.S.C. 103(a) as being unpatentable over Feuerbaum et al. in view of Meisburger et al.. Meisburger et al. teaches to inspect a specimen for defects by detecting charged particles emanating from a specimen scanned by an electron beam, converting the detected charged particles to an electrical signal, storing the picture information conveyed by the electrical signal, and comparing this picture to another picture to detect any defects. (See the last sentence in the abstract.) It would have been obvious to a person having ordinary skill in the art to use Meisburger et al.'s comparison system to compare the picture formed by the electrical signals produced by Feuerbaum et al.'s detector DT to another picture in order to detect defects in the manner taught by Meisburger et al. Meisburger et al. also teaches,

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at lines 27-31 in column 8, to provide an electrode 118 set at a positive electric potential with respect to a negative voltage (which inherently constitutes a deceleration voltage because it decelerates the primary electron beam) applied to electrode 106 between the specimen 57 and the detector 117. It would have been obvious to a person having ordinary skill in the art to provide such an electrode in front of the detector DT in the Feuerbaum et al. apparatus since Meisburger et al. teaches that such an electrode must be provided in order for the electrons to reach the detector with enough energy to be detected.

Claims 7 and 12 are rejected under 35 U.S.C. 103(a) as being unpatentable over Feuerbaum et al. in view of Rose et al.. Rose et al. teaches that crossed electric and magnetic fields can be used to direct secondary electrons emitted by a specimen to a detector without distorting the primary electron beam. It would have been obvious to a person having ordinary skill in the art to incorporate Rose et al.'s electric and magnetic fields into the Feuerbaum et al. apparatus to more effectively detect secondary electrons without adversely affecting the primary electron beam.

Claims 8 and 13 are rejected under 35 U.S.C. 103(a) as being unpatentable over

Feuerbaum et al. in view of Todokoro et al.. Todokoro et al. teaches, in the embodiments

illustrated in Figures 2 and 3 and discussed at line 38 in column 6 through line 44 in column 7,

that in order to detect secondary electrons 23 emitted by a sample 12 in a scanning electron

microscope while minimizing any deflection of the primary electron beam 7 caused by an

electric field (with or without a crossed magnetic field) used to direct the secondary electrons to

the detector, the secondary electrons 23 should be directed to target plate 29 which is coated with

a material which generates secondary electrons upon being struck by secondary electrons 23. It

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would have been obvious to a person having ordinary skill in the art to provide Todokoro et al.'s target plate 29 in the Feuerbaum et al. scanning electron microscope in order to more effectively detect secondary electrons without adversely affecting the primary electron beam.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Jack I. Berman whose telephone number is (703) 308-4849. The examiner can normally be reached on M-F (8:30-6:00) with every second Friday off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, John R. Lee can be reached on (703) 308-4116. The fax phone numbers for the organization where this application or proceeding is assigned are (703) 308-7722 for regular communications and (703) 308-7722 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

Jack I. Berman
Primary Examiner
Art Unit 2881

jb May 30, 2002